ATTORNEY DOCKET NO.: 041501-5551-01

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re C	Continuation Application of:)	
Jong V	Voo KIM et al.)	
Conti	eation No.: To be assigned nuation of Application No.: 10/316,109 December 11, 2002)))	Prior Group Art Unit: 2871
Filed:	February 18, 2004))	Examiner: James A. Dudek
Title:	LIQUID CRYSTAL DISPLAY DEVICE AND METHOD OF FABRICATING THE SAME	,))	

Commissioner for Patents
U.S. Patent and Trademark Office
2011 South Clark Place
Customer Window
Crystal Plaza Two, Lobby, Room 1B03
Arlington, VA 22202

Sir:

INFORMATION DISCLOSURE STATEMENT UNDER 37 C.F.R. § 1.97(b)

Pursuant to 37 C.F.R. §§ 1.56 and 1.97(b), Applicants bring to the attention of the Examiner the documents listed on the attached PTO-1449. This Information Disclosure Statement is being filed within three months of the filing date of the above-referenced continuation application, which is concurrently being filed herewith. The listed documents were previously cited in the co-pending parent Application No. 10/316,109, filed on December 11, 2002, upon which Applicants rely for the benefits provided in 35 U.S.C. § 120. Thus, under 37 C.F.R. § 1.98(d), copies of the listed documents are not being submitted herewith.

Applicants respectfully request that the Examiner consider the listed documents and evidence that consideration by making appropriate notations on the attached PTO-1449 form.

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This submission does not represent that a search has been made or that no better art exists

and does not constitute an admission that each or all of the listed documents are material or

constitute "Prior Art." If it should be determined that any of the listed documents do not

constitute "Prior Art" under United States law, Applicants reserve the right to present to the

Office the relevant facts and law regarding the appropriate status of such document.

Applicants further reserve the right to take appropriate action to establish the patentability

of the disclosed invention over the listed documents, should one or more of the documents be

applied against the claims of the present application.

If there is any fee due in connection with the filing of this Information Disclosure

Statement, please charge the fee to our Deposit Account No. 50-0310.

Respectfully submitted,

MORGAN, LEWIS & BOCKIUS LLP

Dated: February 18, 2004

By:

Robert J/Goodell

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(Use several sheets if necessary)

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Abstract

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Attorney Docket No. Continuation of Application No. INFORMATION DISCLOSURE CITATION 041501-5551-01 10/316,109 Applicant(s): Jong Woo KIM et al. PAGE 6 of 7 (Use several sheets if necessary) PTO Form 1449 Date Filed: February 18, 2004 Prior Group Art Unit: 2871 FOREIGN PATENT DOCUMENTS Translation Sub Document Class Class YES NO Number Date Country 2002-23176 01/23/2002 Abstract Japan 2002-49045 02/15/2002 **Abstract** Japan 2002-82340 03/22/2002 Abstract Japan 2002-90759 03/27/2002 Abstract Japan 2002-90760 03/27/2002 Abstract Japan 2002-107740 04/10/2002 Abstract Japan 2002-122872 04/26/2002 Japan Abstract 2002-122873 04/26/2002 Abstract Japan **Abstract** 2002-139734 05/17/2002 Japan 07/19/2002 Abstract 2002-202512 Japan Abstract 2002-202514 07/19/2002 Japan 2002-214626 07/31/2002 **Abstract** Japan OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.) Date Considered Examiner Initial if reference considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not

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